



ITW  
2812

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Applicant: Alexander Hauser et al.

Serial No.: 10/555,141

Filed: October 31, 2005

Title: METHOD FOR TEXTURING  
SURFACES OF SILICON  
WAFERS

Group Art Unit: 1746

Examiner: Unknown

Docket No.: RAC0082

Conf. No.: 2898

Customer No.: 00832

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Anthony Niewyk, Reg. No. 24,871

Name of Registered Representative

Signature

January 26, 2006

**SUPPLEMENTAL PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to the examination of the above-identified application, please amend the application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Abstract** begin on page 3 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper.

**Remarks** begin on page 6 of this paper.